

Notice of References Cited	Application/Control No. 10/815,061	Applicant(s)/Patent Under Reexamination CHAUDHURI ET AL.	
	Examiner Emeka Ebirim	Art Unit 2166	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-6,598,038 B1	07-2003	Guay et al.	707/2
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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